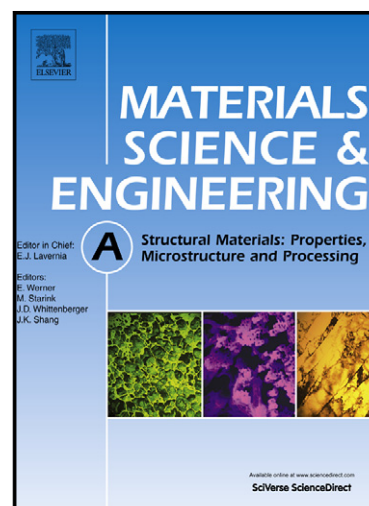


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Surface nanocrystallization of Cu and Ta by sliding friction

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Optimization of the surface structure and properties is of great concern in that the failures of engineering materials such as wear, erosion and fatigue usually occur on the surface of materials. Plastic deformation from the sliding friction process has been utilized to realize surface nanocrystallization in commercial pure copper and tantalum plates in this work. The optical microscopy, transmission electron microscopy, X-ray photoelectron spectra, and uniaxial tensile testing results suggested that clean nanocrystalline surface layers of pure copper and tantalum were obtained, significantly strengthening the materials after the treatment.

Keywords: Nanostructured materials; Non-ferrous alloys; Grain refinement

25 **1. Introduction**

26 A new family of severe plastic deformation processes have attracted considerable
27 scientific interests in order to generate nanocrystalline surface layer for bulk materials
28 [1]. Various surface deformation techniques have been developed by transforming the
29 initial coarse-grained (CG) structure of a bulk material into refined-grain structure,
30 such as surface mechanical attrition treatment (SMAT) [1], air blast shot peening [2],
31 wire-brushing [3], and surface mechanical grinding treatment (SMGT) [4]. These
32 advances enhance several types of mechanical properties while keeping the overall
33 chemical composition of the target material unchanged.

34 Friction is a dissipative process encountered in daily life and industry
35 manufacture. Many experimental results have illustrated that microstructure in the
36 near-surface layer might be changed accordingly during friction and wear process
37 under different contact conditions. Surface microstructure observations showed that
38 plastic deformation could result in the formation of grains with a size falling into
39 nanometer regime. Grains in the surface layer of pure copper with a size less than 60
40 nm have been found in an early study on subsurface structure of pure copper abraded
41 against SiC paper [5]. After sliding against the zirconia disc, the grain size in the
42 surface of the 316 stainless steel could be refined to 8-23 nm [6]. According to
43 Hughes's experimental results, the average geometrically necessary boundaries were
44 only 10 nm, with nanocrystalline surface layer depth in excess of 4 μm [7]. During
45 friction process, only one tenth of the energy was undertaken by wear, while most of
46 the energy was consumed in deformation, heat and noise et. al [8]. Thus it is supposed

47 that in case a suitable process is selected, wear loss can be controlled and more energy
48 can be consumed in plastic deformation. A thick nanocrystalline surface layer in
49 excess of 100 μm underneath the worn surface of pure copper induced by sliding
50 against a WC-Co ball by utilizing a generic friction and wear tester has been reported
51 elsewhere by the current authors [9]. These results further experimentally verified
52 sliding friction as a potential approach to create nanocrystalline structures on the
53 surface layer of metallic materials.

54 As such, we have developed a surface nanocrystallization technology by means
55 of sliding friction treatment (SFT) with a specified device with enlarged sliding
56 amplitude and improved controllable contact condition to scale up sample size. This
57 work described the generation of nanostructured surface layer on pure copper and
58 tantalum by sliding friction process and reported subsequent changes in the
59 mechanical properties of the treated surfaces.

60

61 **2. Experimental procedures**

62 99.95 wt% pure copper and tantalum plates with a size of $200 \times 200 \times 3 \text{ mm}^3$ and a
63 roughness of $0.4 \mu\text{m}$ were annealed at 973 K and 1273 K, respectively, for 60 minutes,
64 in order to eliminate the effect of mechanical processing on the surface and to
65 homogenize the microstructure. The experiments were conducted on a special
66 designed device in a ball-on-disc contact configuration as shown in Fig. 1(a), in which
67 a spherical WC-Co ball of 10 mm in diameter bearing a normal load was static and
68 the specimen (copper or tantalum) subjected to SFT was firmly installed in a table and

69 pressed together with the WC-Co ball under a preset normal force of 100-500 N. The
70 table moved independently along x and y axis driven by two motors. The sliding of
71 the specimen with an amplitude of 50 mm (d_1) at a speed of 0.2 m/s (v_1) with respect
72 to the WC-Co ball along x axis were made firstly, then table with the specimen shifted
73 along the y axis for a step of 100 μm (d_2), and the sliding process continued until the
74 area on the specimen surface is sliding treated. The sliding was carried out under
75 chlorcosane as lubricant for the tantalum while the copper was conducted under a dry
76 condition in an ambient environment. An image of a Cu sheet after SFT with a surface
77 roughness of 0.7 μm and treated surface area of 100 mm \times 150 mm is shown in Fig.
78 1(b).

79 The microstructure of the surface layer of the treated samples was characterized
80 by using an Olympus PMG 3 optical microscopy (OM) and a JEOL JEM-2100
81 transmission electron microscope (TEM) operated at a voltage of 200 kV. Thin foil
82 samples for TEM observations were cut from the treated surface layer and thinned by
83 ion thinning at low temperatures.

84 X-ray photoelectron spectroscopy (XPS) was carried out on a Thermo Fisher
85 ESCACAB 250XI spectrometer, by using monochromatic Al K α radiation and
86 detection pass energy ranging between 30 and 100 eV. Argon sputtering was applied
87 at a pressure of 1×10^{-7} Pa under a 3 kV beam accelerating voltage.

88 The as-treated plates were mechanically polished on the top surface to remove 1-2
89 μm in depth to eliminate the roughness effect on tensile properties. Down-sized
90 tensile specimens shown in Fig. 1(c) were cut with the testing direction along the

91 sliding direction by using electro-discharging machining. Afterwards, mechanical
92 polishing was performed from back side of the treated sample to a mirror finish with a
93 designed thickness. Tensile tests were performed on a Tytron 250 Microforce Testing
94 System (MTS System Corporation, with a precision of force measurement of 10 mN)
95 at a strain rate $5 \times 10^{-3} \text{ s}^{-1}$ at room temperature. A contactless MTS LX300 Laser
96 extensometer was used to calibrate and measure the strain of the tested sample during
97 loading.

98

99 **3. Results and discussion**

100 Figure 2 shows the microstructure from longitudinal cross-section of the Cu
101 sample before and after SFT. Plastic deformation and traces of plastic flow are
102 evident in the treated surface layer, instead of the original CG structure. After SFT at
103 100 N, the topmost deformed subsurface layer features discontinuous in a wave
104 pattern. This is similar to the vortex structure appeared in some local zones of the
105 upmost worn subsurface, which has been usually found [10-12] and checked in details
106 by Yao [13] to be composed of severely refined grains. It is apparent that the plastic
107 flow lines extended to a greater depth as the load increases to 200 N, and the
108 deformed subsurface layer tends to be continuous, with grain boundaries bent towards
109 one direction with decreasing depth toward the surface.

110 As revealed by TEM morphologies and the corresponding selected area electron
111 diffraction (SAED) pattern in Figs. 2(d) and (e), elongated grains with random
112 crystallographic orientations are formed in the top surface layer of the sample. The

113 average transverse axis grain size (d_t) and longitudinal axis grain size (d_l) are 60 and
114 110 nm, respectively, although a certain number of grains approaching 200 nm are
115 also present. The grain size is slightly larger than that in the surface layer of the Cu
116 sample subjected to SMGT (22 nm, 45 nm in transverse axis and longitudinal axis
117 size respectively) under liquid nitrogen [4] and SMAT (10 nm) for 30 min [14].

118 Microstructures of the longitudinal cross-sectional Ta sample before and after
119 SFT are presented in Figs. 3(a)-(c). Initial Ta sample has an equiaxed grain structure
120 with size of 30-60 μm (Fig. 3(a)), and after SFT at a load of 200 N, a plastic deformed
121 surface layer with the thickness exceeding 100 μm is formed clearly as shown in Fig.
122 3(b). When sliding load increases to 500 N, the deformation layer of about 300 μm in
123 depth is reached, as revealed in Fig. 3(c). Plastic flow lines are inclined to the surface
124 as they approached the worn surface, similar to the case for Cu in Fig. 2(c). The
125 detailed TEM observations show that roughly equiaxed grains with size ranging from
126 3 to 15 nm and an average grain size of 7 nm are formed in the topmost layer (Figs.
127 3(d) and (e)).

128 Materials in sliding contact develop large plastic strain and strain rate adjacent to
129 the sliding interface in that actual contact took place in some asperities of the friction
130 pair. Plastic shear strains in the range of 10–1000 have been reported [7, 15-17]. For
131 example, based on the volume grain boundary area and von Mises relation, Hughes
132 [17] extrapolated that the strain in the top-surface of copper subjected to friction was
133 roughly 25 and the maximum shear strain rates being up to $5 \times 10^3 \text{ s}^{-1}$. Owing to much
134 high strain and high strain rate, a nanocrystalline structure will be produced, which

135 had been validated by large-scale molecular dynamics simulations [18] and
136 considerable amounts of experiments over the past several decades [5-7, 19]. Current
137 SFT has induced nanocrystalline structure on the subsurface for both Cu and Ta, and
138 finer grain size for Ta than that for Cu may be attributed to the difficulty in
139 dislocations recovery due to its higher melting temperature.

140 XPS results (Fig. 4) showed that C and O coming from the mating ball or
141 atmosphere were detected on the treated surface of the Cu and Ta samples, while the
142 impurity contents decreased remarkably away from the surface. For example, after
143 etching 840 s, the C content was decreased by two orders of magnitude for the two
144 samples. The measured values from XPS are summarized in Table 1. It is reasonable
145 to obtain clean nanocrystalline surface layer for Ta because the lubricant oil used
146 could alleviate wear and isolate the air from the contact surfaces. For the metals
147 sliding in air, it is common to produce oxides which are then available to
148 mechanically mix with unoxidized metal to form a mechanically mixed surface layer
149 [16, 20, 21]. In this work, large moving distance up to 50 mm imposed played a
150 dominant role in reducing impurity of the surface layer. Compared with our previous
151 study with a much lower travel distance (0.5 mm), the severe oxidation process and
152 subsequent behavior of oxide debris in between contact surfaces subjected to relative
153 slip will result in the thick oxide layer [22]. While in the present study during the
154 large distance sliding, the heat generated during friction should be radiated easily,
155 which can significantly alleviate oxidation. Moreover, it benefitted for the oxide
156 debris and contamination from transferred materials to be removed from the contact

157 zone. Consequently, a much thinner contamination layer was generated on the
158 nanostructured surface layer of the treated sample.

159 Results from uniaxial tensile tests in Fig. 5 showed that the nanocrystalline
160 samples exhibited much higher yield strength (YS) and ultimate tensile strength (UTS)
161 compared with their CG counterparts for both Ta and Cu. The YS of the SFT Cu and
162 SFT Ta have reached 450 MPa and 720 MPa, respectively, which are considerably
163 higher than that of the corresponding CG samples (75 MPa for Cu and 300 MPa for
164 Ta). However, the plasticity was depressed for the nanocrystalline samples, with an
165 elongation-to-failure less than 2% for both materials. It was reasonable that
166 nanocrystalline grains tended to significantly lose work hardening on deformation
167 owing to their very low dislocation storage efficiency inside tiny grains [23]. It was
168 noted that the SFT Cu with a 200 μm in thickness exhibited a YS of 300 MPa and a
169 moderate elongation of 4.4. It was in well agreement with the results in [24] and
170 further verified that an approach using gradient nano-grained layers as advanced
171 coatings of bulk materials could enhance strength-ductility synergy of materials.

172

173 **4. Conclusions**

174 The sliding friction was used to refine the grain structure on the surface of pure
175 Cu and Ta plates with a size scale up to 100 mm \times 150 mm. The average grain size in
176 the upmost surface layer of the Cu and Ta can be reduced down to 60 nm and 7 nm
177 respectively. Surface contaminated layer from the ball-disc sliding is reasonably low
178 in depth. The yield strength of the Cu and Ta has been improved from 75 MPa and

179 300 MPa to 450 MPa and 720 MPa after SFT, respectively. Current study revealed
180 that SFT was a promising process to realize nanocrystalline material surface with a
181 low contamination.

182 **Acknowledgements**

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- 217

218 **Table 1.** Variations of the element contents (in wt. %) with sputtering time from the
219 treated surface in the SFT samples.

220

SFT Cu				
	0 s	60 s	240 s	840 s
221 Cu	31	91.2	98.8	99.5
222 O	22	1.89	0.35	0.11
C	47	6.91	0.85	0.39

223

SFT Ta				
	0 s	60 s	240 s	840 s
224 Ta	35.55	82.5	95.68	98.61
O	29.35	16.16	3.46	1.34
225 C	35.1	1.34	0.86	0.25

226

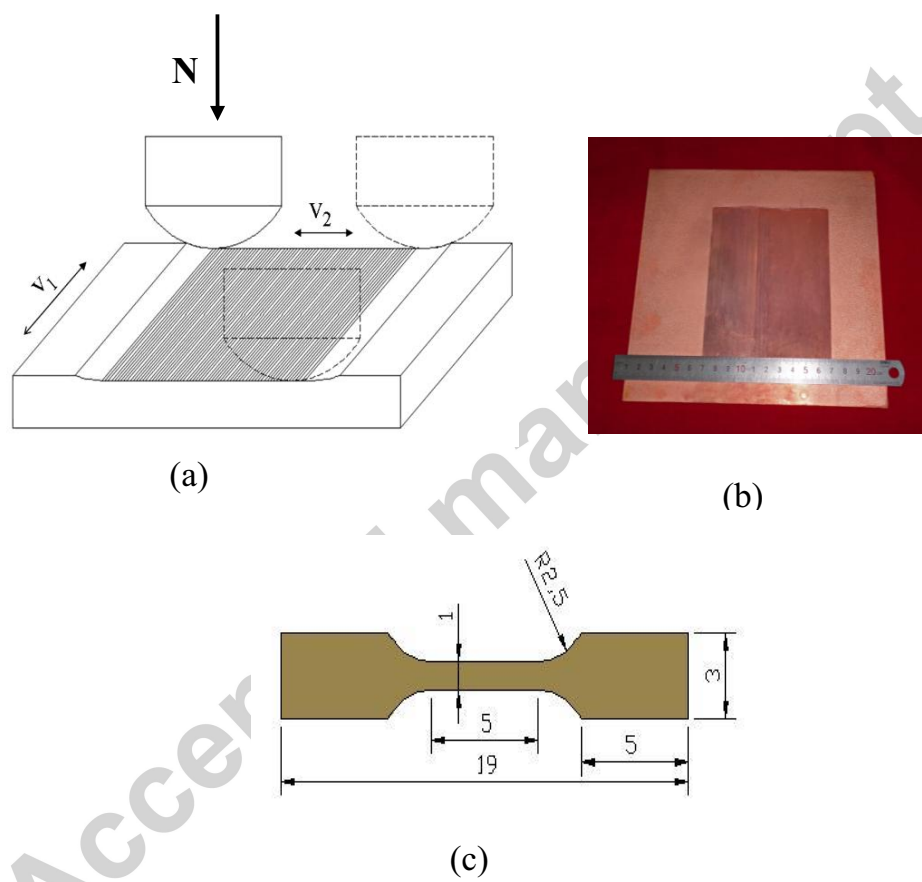


Figure 1. (a) Schematic illustrations of the sliding friction treatment set-up, (b) a photograph of a Cu sheet after sliding friction treatment and (c) the geometry of the tensile specimen.

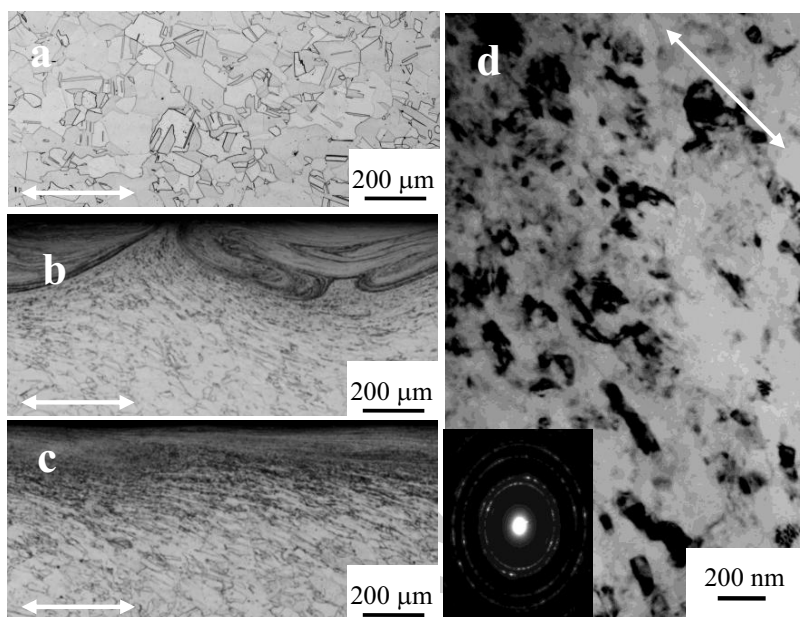


Figure 2. Cross-sectional optical images of (a) the original and SFT Cu samples under load of (b) 100 N and (c) 200 N, (d) a bright-field TEM image and a corresponding SAED insert showing the microstructure at the topmost surface in (c). Doubly pointed arrow indicates the sliding direction.

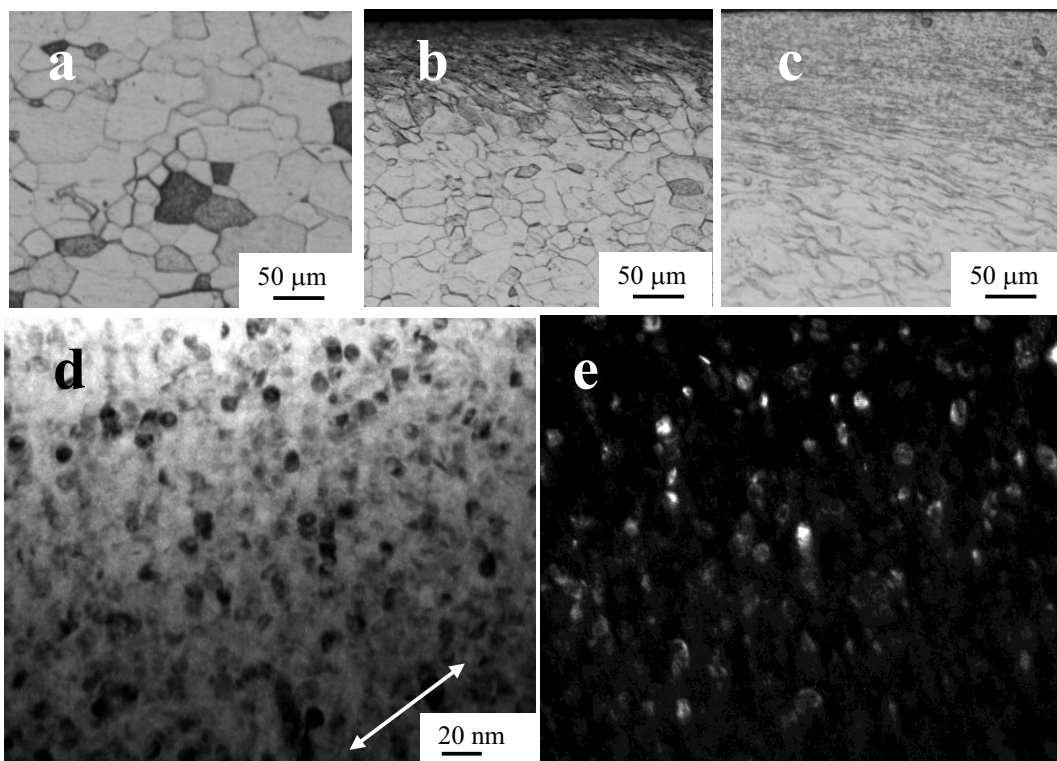


Figure 3. Cross-sectional optical images of (a) the original and SFT Ta samples under load of (b) 200 N and (c) 500 N. (d) A bright-field TEM image and (e) a dark-field TEM image showing the microstructure at the topmost surface layer in (c). Doubly pointed arrow indicates the sliding direction.

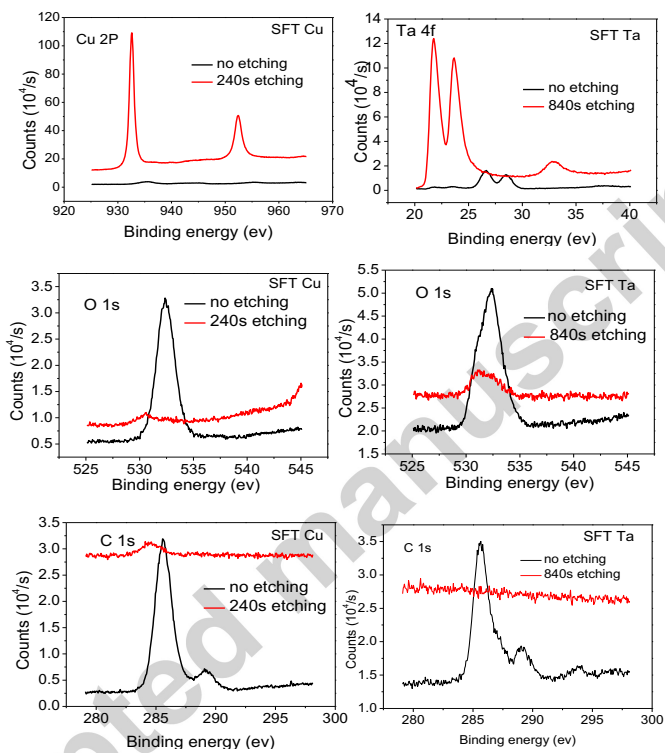


Figure 4. X-ray photoelectron spectra at different etching depths from the surface in the SFT Cu and Ta samples.

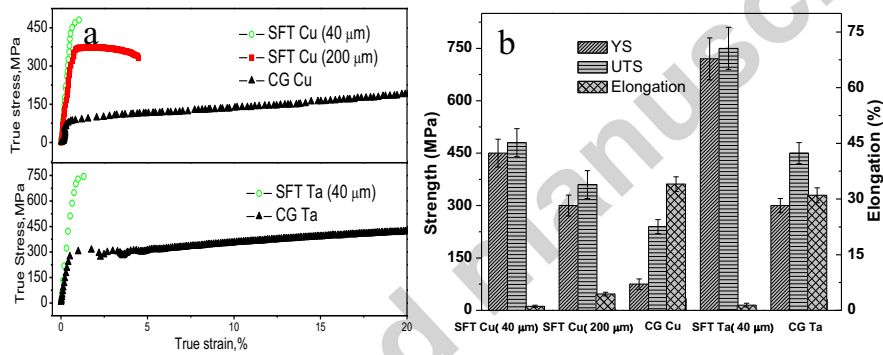


Figure 5. (a) Tensile true stress-strain curves and dimensions of the tensile sample (inset), and (b) summaries of the data of the surface layer in SFT samples with different thickness as indicated, in comparison with the corresponding CG samples.